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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

BRIAN VIALPANDO ET AL.

Serial No. 10/727,392 (TI-35829)

Filed December 4, 2003

For: A THIN FILM RESISTOR STRUCTURE AND METHOD  
OF FABRICATING A THIN FILM RESISTOR STRUCTURE

Art Unit 1765

Examiner Shamim Ahmed

Customer No. 23494

Mail Stop Amendment  
Commissioner for Patents  
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**AMENDMENT UNDER 37 C.F.R. 1.116**

In response to the Office action dated March 31, 2006, the following remarks are  
presented: